



DOCKET NO.: H0498.70173US00

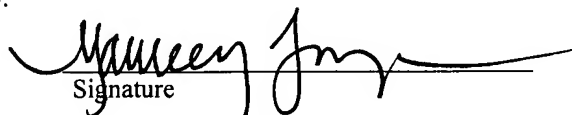
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Rahul Singhvi, et al.
Serial No.: 10/032,280
Confirmation No.: 6387
Filed: December 21, 2001
For: METHOD OF FORMATION OF MICROSTAMPED
PATTERNS OF PLATES FOR ADHESION OF CELLS
AND OTHER BIOLOGICAL MATERIALS, DEVICES
AND USES THEREFOR

Examiner: Deborah K. Ware
Art Unit: 1651

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to MAIL STOP RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 1 day of September, 2005.


Signature

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**STATEMENT FILED PURSUANT TO THE DUTY OF
DISCLOSURE UNDER 37 C.F.R. §§1.56, 1.97 AND 1.98**

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. §§1.56, 1.97 and 1.98, the Applicants request consideration of this Information Disclosure Statement.

PART I: Compliance with 37 C.F.R. §1.97

This Information Disclosure Statement has been filed before the mailing of a first Office Action after the filing of a request for continued examination under 37 C.F.R. §1.114. No fee or certification is required.

PART II: Information Cited

The Applicants hereby make of record in the above-identified application the information listed on the attached form PTO-1449 (modified). The order of presentation of the references should not be construed as an indication of the importance of the references.

The Applicant would like to bring to the Examiner's attention the following co-pending applications that may contain subject matter related to this application:

<u>Serial No.</u>	<u>Filing Date</u>	<u>Inventor(s)</u>
10/776,427	February 11, 2004	George M. Whitesides, et al.

PART III: Explanation of Non-English Language References and Remarks Concerning Other Information Cited

The following is a concise explanation of the relevance of each non-English language reference listed on the attached form PTO-1449 (modified):

Japanese reference JP 2140702 generally teaches a rotary variable focal mirror.

Japanese reference JP 2165933 generally teaches manufacture of microlens arrays.

Japanese reference JP 2210302 generally teaches a focal distance variable mirror.

Japanese reference JP 58150148 generally teaches production of a stamper.

Applicants have provided translations of the abstracts of the foreign language references from the Japanese Patent Office. These translations are not the Applicants' translations. Applicants do not concede to the accuracy of these translations, but are not aware of any inaccuracies.

The following are remarks concerning the other information cited:

PART IV: Remarks

Documents cited anywhere in the Information Disclosure Statement are enclosed unless otherwise indicated. It is respectfully requested that:

1. The Examiner consider completely the cited information, along with any other information, in reaching a determination concerning the patentability of the present claims;
2. The enclosed form PTO-1449 be signed by the Examiner to evidence that the cited information has been fully considered by the Patent and Trademark Office during the examination of this application;
3. The citations for the information be printed on any patent which issues from this application.

By submitting this Information Disclosure Statement, the Applicants make no representation that a search has been performed, of the extent of any search performed, or that more relevant information does not exist.

By submitting this Information Disclosure Statement, the Applicants make no representation that the information cited in the Statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).


By submitting this Information Disclosure Statement, the Applicants make no representation that the information cited in the Statement is, or is considered to be, in fact, prior art as defined by 35 U.S.C. §102.

Notwithstanding any statements by the Applicants, the Examiner is urged to form his or her own conclusion regarding the relevance of the cited information.

An early and favorable action is hereby requested.

Respectfully submitted,

By:



Timothy J. Oyer, Ph.D., Reg. No. 36,628
Wolf, Greenfield & Sacks, P.C.
600 Atlantic Avenue
Boston, Massachusetts 02210-2206
Telephone: (617) 646-8000

Docket No.: H0498.70173US00
Date: September 1, 2005
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FORM PTO-1449/A and B (Modified) INFORMATION DISCLOSURE STATEMENT BY APPLICANT			APPLICATION NO.: 10/032,280		ATTY. DOCKET NO.: H0498.70173US00	
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			GROUP ART UNIT: 1651		EXAMINER: Deborah K. Ware	
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	B2	JP	2140702		Hidehiko	05-30-1990	Y, abstract only
	B3	JP	2165933		Motoyuki	06-26-1990	Y, abstract only
	B4	JP	2210302		Yasutsugu	08-21-1990	Y, abstract only
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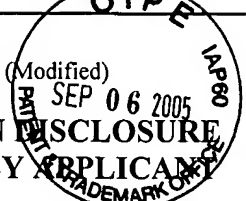
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	C5	BHATIA, SURESH K., et al., "Fabrication of Surfaces Resistant to Protein Adsorption and Application to Two-Dimensional Protein Patterning", Anal. Biochem., vol. 208, pp. 197-205 (1993)	
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	C7	BLANKENSTEIN & LARSEN, "Modular concept of a laboratory on a chip for chemical and biochemical analysis," Biosensors & Bioelectronics, Vol. 13, No. 3-4, pp. 427-438, 1998	
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OTHER ART — NON PATENT LITERATURE DOCUMENTS

Examiner's Initials	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation (Y/N)
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FORM PTO-1449/A and B (Modified)			APPLICATION NO.: 10/032,280	ATTY. DOCKET NO.: H0498.70173US00
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILING DATE: 12/21/2001	CONFIRMATION NO.: 6387
			APPLICANT: Rahul Singhvi, et al.	
			GROUP ART UNIT: 1651	EXAMINER: Deborah K. Ware
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